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U.S. DEPARTMENT OF COMMERCE Form PTO-1449 ATTY. DOCKET NO. SERIAL NO. PATENT AND TRADEMARK OFFICE MI22-2514 Filed Herewith LIST OF ART CITED BY APPLICANT APPLICANT H. Daniel Dulman et al. (Use several sheets if necessary) FILING DATE Filed Herewith GROUP Unknown U.S. PATENT DOCUMENTS Document Number Examiner Date Name Class Subclass Filing Date Initial If Appropriate SPM AA 5,308,721 05/94 Garofalo et al. AB AC AD ΑE ΑF AG AΗ ΑI ΑJ ΑK AL FOREIGN PATENT DOCUMENTS Class Date Document Country Subclass Number Yes No ΑM AN ΑO ΑP ΑQ OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.) AR Kobayashi, S. et al., "Development of Simplified Process for KrF Excimer Half-Tone Mask with Chrome-Shielding Method", Sem 19th Annual BACUS Sympos. on Photomask Technology, Monterey, CA, 9/99, SPIE Vol. 3873 (1999), pp. 288-296. AS Kobayashi, S. et al., "Development of Simplified Process for KrF Excimer Half-Tone Mask with Chrome-Shielding Method SRIM (II)*, 20th Annual BACUS Sympos on Photomask Technology, Proceedings of SPIE Vol. 4186 (2001), pp.801-809. **EXAMINER** Mohame DATE CONSIDERED 8/23/04 *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.